



COMMISSIONER FOR PATENTS
UNITED STATES PATENT AND TRADEMARK OFFICE
P.O. BOX 1450
ALEXANDRIA, VA 22313-1450
www.usplo.gov

MAR 1 8 2004

In re Application of

Jeng H. Hwang

Serial No. 09/896,786

Filed: June 29, 2001

For: METHOD FOR ALLOWING A STABLE

POWER TRANSMISSION INTO A PLASMA

PROCESSING CHAMBER

NOTICE OF WITHDRAWAL FROM ISSUE

UNDER 37 CFR 1.313(b)

The above-identified application is withdrawn from issue after payment of the issue fee due to reopening of prosecution. See 37 CFR 1.313 (b).

The above-identified application is hereby withdrawn from issue.

The issue fee is refundable upon written request. If, however, the application is again found allowable, the issue fee can be applied toward payment of the issue fee in the amount identified on the new Notice of Allowance and Issue Fee Due upon written request. This request and any balance due must be received on or before the due date noted in the new Notice of Allowance in order to prevent abandonment of the application.

Telephone inquiries should be directed to at Gregory Mills (703) 308-1633.

The above-identified application is being forwarded to the examiner for prompt appropriate action, including notifying applicant of the new status of this application.

Motore

Jacqueline Stone, Director Technology Center 1700 Chemical and Materials Engineering

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cc: Allowed Files-Pk3-910